



Examiner: John P. Sheehan

52433/766

Art Unit Docket No.:

1742

Conf. No. :

1853

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants

Y. USHIGAMI et al.

Serial No.

10/500,994

Filed

January 12, 2005

For

METHOD FOR MANUFACTURING GRAIN-ORIENTED SILICON

STEEL SHEETS WITH MIRROR-LIKE SURFACE

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

TRANSMITTAL LETTER

SIR:

Transmitted herewith is an Amendment/Response in the above-identified patent application.

No additional fee is required. [X]

The fee has been calculated as shown below.

					SI.	MALL ENTITY	OTHER THAN A SMALL ENTITY		
CLAIMS REMAINING AFTER AMENDMENT	PREVIC PAI	HEST USLY D FOR	PRES	ENT XTRA	RATE	ADDIT. OR FEE	RATE	ADDIT. FEE	
TOTAL 12	MINUS	20	=	0	x6=	\$	x18 =	\$ 0.0	50
INDEP. 4	MINUS	5	=	0	x18=	\$	x84 =	\$ 0.0	00
[]FIRST PRESENTATION OF MULTIPLE				×60=	\$	x280=	\$ 0.0	00	
DEP. CLAIM				T	OTAL				_
				AI	DDIT. FEE	\$ OR		\$0.0	00

[X]The Commissioner is hereby authorized to charge fees under 37 CFR 1.16 and 1.17 which may be required to Deposit Account 11-0600. A duplicate of this paper is enclosed.

[] A petition for a ___ (__) month extension of time and Deposit Account authorization to cover the extension fee are enclosed.

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on October 10, 2007.

Respectfully submitted,

KENYON & KENYON LLP

Reg. No. 29,182

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on October 10, 2007.

John J. Kelly, Jr. Reg. No.: 29,182

CT 1 5 2007

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AMENDMENT

SIR:

Reconsideration of the above-identified patent application, as amended, is respectfully requested. The present amendment is responsive to the Office Action mailed July 25, 2007.